

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tetsuhiro Iwai et al.
Title: "PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD"
Serial No.: N/A
Filed: Herewith
Docket: 35908

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir/Madam:

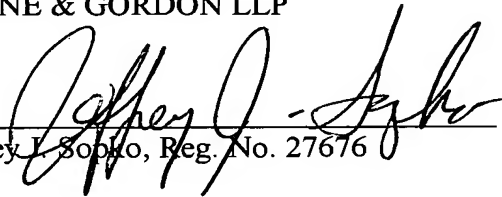
In accordance with 37 C.F.R. § 1.98, applicant is submitting herewith Form PTO-1449 listing references for consideration by the Examiner. Also submitted herewith is a legible copy of each reference listed.

If there are any fees required by this communication, please charge such fees to our Deposit Account No. 16-0820, Order No. 35908.

Respectfully submitted,

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By


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Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 35908	SERIAL NO. N/A
INFORMATION DISCLOSURE CITATION BY APPLICANT <i>(USE SEVERAL SHEETS IF NECESSARY)</i>		APPLICANT: Tetsuhiro Iwai et al.	
		FILING DATE: Herewith	GROUP ART UNIT:

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L	2000-173982	06/2000	Japan			English Abstract
	M	2001-284332	10/2001	Japan			English Abstract
	N	2002-305171	10/2002	Japan			English Abstract
	P						
	Q						

OTHER REFERENCES <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>

	R	
	S	

Examiner:	Date Considered
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*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.